

Papers presented in conferences

1. Influence of oxygen partial pressures on the optical properties of Dc reactive magnetron sputtered Cu_2O films
A. Sivasankar Reddy, S. Uthanna and P. Sreedhara Reddy
National Conference on Emerging Materials and Technologies – 2004 held at Tirupati, Andhra Pradesh.
2. Preparation and structural studies on dc magnetron sputtered Cu_2O films
A. Sivasankar Reddy, P. Sreedhara Reddy and S. Uthanna
National Workshop on Thin Film Techniques and Applications – 2004, held at Coimbatore, India.
3. Influence of sputtering pressure on the optical properties of dc reactive magnetron sputtered Cu_2O films
A. Sivasankar Reddy, P. Sreedhara Reddy and S. Uthanna
Proceedings of the DAE Solid State Physics Symposium – 2004 held at Amritsar, Punjab, Vol.49 (2004) pp. 524.
4. Influence of oxygen partial pressure on the structural and electrical properties of Cu_2O films
A. Sivasankar Reddy, S. Uthanna and P. Sreedhara Reddy
International Conference on Optoelectronic Materials and Thin Films for Advanced Technology – 2005 held at Kochi, Kerala.
5. Structural and electrical characterization of dc reactive magnetron sputtered Cu_2O films
A. Sivasankar Reddy, S. Uthanna and P. Sreedhara Reddy
National Symposium on Vacuum Science Technology and its application to Plasmas-2005 held at Gandhinagar, Gujarat.
6. Optical properties of dc magnetron sputtered Cu_2O films
A. Sivasankar Reddy, S. Uthanna and P. Sreedhara Reddy
International Conference on Optics and Optoelectronics - 2005, Dehradun, Uttaranchal.
7. Optical properties of dc magnetron sputtered CuAlO_2 films at different oxygen partial pressures
A. Sivasankar Reddy, S. Uthanna and P. Sreedhara Reddy
National Conference on Novel Materials and Technologies – 2006, Tirupati, Andhra Pradesh.